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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Sheu, *et al.* Docket No.: TSM03-0140  
Serial No.: 10/619,828 Art Unit: 2829  
Filed: July 15, 2003 Examiner: Dana Farahani  
For: Self-Aligned MOSFET having an Oxide Region below the Channel

**Certificate of Mailing via First Class Mail (37 C.F.R. § 1.8(a))**

Date of Deposit: May 16, 2005

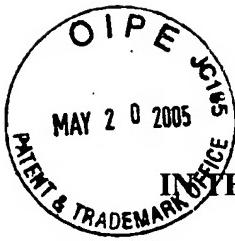
I hereby certify that the following documents, which are enclosed, are being deposited with the United States Postal Service "First Class Mail Post Office to Addressee" service under 37 C.F.R. § 1.10 on the date indicated above in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P. O. Box 1450, Alexandria, VA 22313-1450:

Certificate of Mailing via First Class Mail (1 page)  
Response to Office Action (4 pages)  
Information Disclosure Statement (1 original and 1 copy = 2 pages)  
IDS Form PTO/SB/08a and 08b (6 pages) citing 52 references  
Copies of (5) references  
Return Postcard

Respectfully submitted,

Judy A. Betts  
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Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**Response to Office Action**

Dear Sir:

Applicants respectfully submit the following remarks in response to Examiner's Office Action mailed February 16, 2005. They are believed to be a full and complete response to said Action.